

In re Applicant:

Tongbi Jiang et al.

Art Unit:

3729

Serial No.:

10/689,471

Examiner:

Minh N. Trinh

Filed:

For:

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A Method For Forming A Stencil

(As Amended)

Docket:

MCT.0015C2US

97-0524.04US

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed August 31, 2005, please amend the abovereferenced patent application as follows:

Date of Deposit: September 19, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450,